



the Application of:

SEONG DEOK AHN, ET AL.

Application No.: 10/672,013

Filed: September 26, 2003

METHOD AND APPARATUS USING For:

> LARGE-AREA ORGANIC VAPOR DEPOSITION FOR FORMATION OF ORGANIC THIN FILMS OR ORGANIC

Art Group: 1763

Examiner: Richard R. Bueker

PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136(a)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F. R. § 1.136(a), Applicants for the above-identified application respectfully Petition the Commissioner for a one (1) month extension of time, extending the period for response to April 01, 2007, from the Office Action dated December 01, 2006. The petition filing fee of \$60.00 and an Amendment and Response to Office Action are attached. (If a check is not attached, you are hereby authorized to charge deposit account no. 02-2666.)

If it should be determined that a longer extension of time is required to prevent this application from being abandoned, please charge any additional fees to Deposit Account No. 02-2666. A copy of the Fee Transmittal is enclosed for deposit account charging purposes.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP

Eric S. Hyman, Reg. No. 30,139

12400 Wilshire Boulevard, 7th Floor Los Angeles, CA 90025

Date: Mourch 30, 2007

Telephone: (310) 207-3800

CERTIFICATE OF MAILING/TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.